



<b>AMENDMENT TRANSMITTAL LETTER</b>				Docket No. SON-2612/DIV
Application No. 10/785,005-Conf. #9742	Filing Date February 25, 2004	Examiner T. X. Le	Art Unit 2814	
Applicant(s): Shigeru Fujita				
Invention: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD				
<b>TO THE COMMISSIONER FOR PATENTS</b>				
Transmitted herewith is an amendment in the above-identified application.				
The fee has been calculated and is transmitted as shown below.				
<b>CLAIMS AS AMENDED</b>				
Total Claims	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
9	- 20 =		X	0.00
Independent Claims	2	- 3 =	X	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify):				
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b> <input type="text"/> 0.00				
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input checked="" type="checkbox"/> No additional fee is required for this amendment.				
<input type="checkbox"/> Please charge Deposit Account No. <input type="text"/> in the amount of \$ <input type="text"/> A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ <input type="text"/> to cover the filing fee is enclosed.				
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
Dated: <u>March 28, 2005</u>				
Ronald P. Kanänen Attorney Reg. No.: <u>24,104</u>				
RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750				
DC187820				



Docket No.: SON-2612/DIV  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

*Confirmation No.: 9742*

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE STRUCTURE  
THAT PREVENTS P-TYPE IMPURITY  
DIFFUSION (As Amended)

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Examiner: T. X. Le

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 26, 2004 (Paper No. 101304), please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 4 of this paper.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 4 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.